EAST Search History

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	1420	(117/900;117/213;419/39;419/56).ccls.	US-PGPUB; USPAT; USOCR	ADJ	OFF	2008/06/05 15:45
L2	3822	(423/406 OR 428/698 OR 423/344).ccls.	US-PGPUB; USPAT; USOCR	ADJ	OFF	2008/06/05 15:45
L3	37	(L1 OR L2) AND silicon nitride AND crucible AND porosity	US-PGPUB; USPAT; USOCR	ADJ	OFF	2008/06/05 15:46
L4	0	"117"."213".ccls.	US-PGPUB; USPAT; USOCR	ADJ	OFF	2008/06/05 16:04
L5	168	117/213.ccls.	US-PGPUB; USPAT; USOCR	ADJ	OFF	2008/06/05 16:04
L6	7	L5 and porosity	US-PGPUB; USPAT; USOCR	ADJ	OFF	2008/06/05 16:06
L7	0	L5 and (pore size)	US-PGPUB; USPAT; USOCR	ADJ	OFF	2008/06/05 16:07
L8	0	L5 and (pore WITH size)	US-PGPUB; USPAT; USOCR	ADJ	ON	2008/06/05 16:07
S1	1	"20040211496".did.	US-PGPUB; USPAT; USOCR	ADJ	OFF	2007/10/03 15:32
S2	36	silicon nitride NEAR crucible	US-PGPUB; USPAT; USOCR	ADJ	OFF	2007/10/03 15:33
S3	3	silicon nitride NEAR crucible AND pore	US-PGPUB; USPAT; USOCR	ADJ	OFF	2007/10/03 15:34
S4	3	silicon nitride NEAR3 crucible AND pore	US-PGPUB; USPAT; USOCR	ADJ	OFF	2007/10/03 15:39
S5	17	silicon nitride NEAR3 crucible AND (pore OR porous)	US-PGPUB; USPAT; USOCR	ADJ	OFF	2007/10/03 16:10
S6	1	"4515755".pn.	US-PGPUB; USPAT; USOCR	ADJ	OFF	2007/10/03 16:11
S7	30	silicon nitride NEAR3 crucible AND (pore OR porous OR porosity OR pores)	US-PGPUB; USPAT; USOCR	ADJ	OFF	2007/12/07 09:30
S8	61	silicon nitride NEAR3 (crucible OR mould OR mold) AND (pore OR porous OR porosity OR pores)	US-PGPUB; USPAT; USOCR	ADJ	OFF	2007/12/07 09:31
S9	276	silicon nitride WITH (crucible OR mould OR mold) AND (pore OR porous OR porosity OR pores)	US-PGPUB; USPAT; USOCR	ADJ	OFF	2007/12/07 09:32
S10	3762	(423/406 OR 428/698 OR 423/344).ccls.	US-PGPUB; USPAT; USOCR	ADJ	OFF	2007/12/07 09:32
S11	19	S9 and S10	US-PGPUB; USPAT; USOCR	ADJ	OFF	2007/12/07 09:32
S12	31	silicon nitride WITH (crucible OR mould OR mold) AND (open WITH (pore OR porous OR porosity OR pores))	US-PGPUB; USPAT; USOCR	ADJ	OFF	2007/12/07 09:42
S13	160	silicon nitride WITH (crucible OR mould OR mold) AND (pore OR porous OR porosity OR pores) AND (coat OR coating OR coated)	US-PGPUB; USPAT; USOCR	ADJ	OFF	2007/12/07 10:23
S14	2882	silicon nitride SAME (pore OR porous OR porosity OR pores) AND (coat OR coating OR coated)	US-PGPUB; USPAT; USOCR	ADJ	OFF	2007/12/07 10:36
S15	92	S10 and S14	US-PGPUB; USPAT; USOCR	ADJ	OFF	2007/12/07 10:36

S16	1978	silicon nitride SAME (pore OR porous OR porosity OR pores) AND (coat OR coating OR coated) AND (particle OR powder OR particulate OR granule)	US-PGPUB; USPAT; USOCR	ADJ	ON	2007/12/07 10:36
S17	79	S16 and S10	US-PGPUB; USPAT; USOCR	ADJ	ON	2007/12/07 10:38
S18	94	silicon nitride WITH (crucible OR mould OR mold) AND (pore OR porous OR porosity OR pores)	DERWENT	ADJ	OFF	2007/12/07 10:43
S19	1	"20040211496".did.	US-PGPUB; USPAT	ADJ	OFF	2007/12/07 15:02
S20	50	(silicon nitride OR SiN) WITH (crucible OR mould OR mold) AND (open WITH (pore OR porous OR porosity OR pores))	US-PGPUB; USPAT; USOCR	ADJ	OFF	2008/05/29 16:33
S21	477	(SiN OR silicon nitride) AND crucible AND "117".clas.	US-PGPUB; USPAT; USOCR	ADJ	OFF	2008/05/29 16:34
S22	259	(silicon nitride) AND crucible AND "117".clas.	US-PGPUB; USPAT; USOCR	ADJ	OFF	2008/05/29 16:36
S23	2110	"L4" and (pore OR pores OR porosity)	US-PGPUB; USPAT; USOCR	ADJ	OFF	2008/05/29 16:37
S24	35	S21 and (pore OR pores OR porosity)	US-PGPUB; USPAT; USOCR	ADJ	OFF	2008/05/29 16:37
S25	56	(silicon nitride OR SiN) WITH (crucible OR mould OR mold) AND (open WITH (pore OR porous OR porosity OR pores))	US-PGPUB; USPAT; USOCR	ADJ	ON	2008/05/29 16:40
S26	261	(silicon nitride) AND crucible AND "117".clas.	US-PGPUB; USPAT; USOCR	ADJ	ON	2008/05/29 16:44
S27	476	(423/344).ccls.	US-PGPUB; USPAT; USOCR	ADJ	OFF	2008/05/29 17:08
S28	320	S27 and (nitriding OR nitride OR nitrogen OR nitrificate OR nitrification)	US-PGPUB; USPAT; USOCR	ADJ	OFF	2008/05/29 17:08
S29	85	S28 and (pore OR porosity)	US-PGPUB; USPAT; USOCR	ADJ	ON	2008/05/29 17:09
S30	73	S29 and silicon nitride	US-PGPUB; USPAT; USOCR	ADJ	ON	2008/05/29 17:27
S31	476	(423/344).ccls.	US-PGPUB; USPAT; USOCR	ADJ	OFF	2008/05/30 11:05
S32	320	S31 and (nitriding OR nitride OR nitrogen OR nitrificate OR nitrification)	US-PGPUB; USPAT; USOCR	ADJ	OFF	2008/05/30 11:05
S33	85	S32 and (pore OR porosity)	US-PGPUB; USPAT; USOCR	ADJ	ON	2008/05/30 11:05
S34	73	S33 and silicon nitride	US-PGPUB; USPAT; USOCR	ADJ	ON	2008/05/30 11:05
S35	28	S34 and ((low WITH density) OR (high WITH porosity))	US-PGPUB; USPAT; USOCR	ADJ	ON	2008/05/30 11:05
S36	28	S34 and ((low WITH density) OR (high WITH porosity) OR (large WITH pore WITH size))	US-PGPUB; USPAT; USOCR	ADJ	ON	2008/05/30 11:06
S38	13	S34 and (naphthalene OR phenol OR resin)	US-PGPUB; USPAT; USOCR	ADJ	ON	2008/05/30 12:15
S39	13	S34 and (naphthalene OR phenol OR phenolic OR resin)	US-PGPUB; USPAT; USOCR	ADJ	ON	2008/05/30 12:36

S40	22	(US-20020164475-$ or US-20030186800-$).did. or (US-5968426-$ or US-4515755-$ or US-3950464-$ or US-4090851-$ or US-4661461-$ or US-4310477-$ or US-4187344-$ or US-5866245-$ or US-3778231-$ or US-5332697-$ or US-5399536-$).did. or (US-2618565-$).did. or (DE-2734772-$ or JP-74015043-$ or SE-8008654-$ or JP-61222966-$ or JP-01188479-$ or JP-08217567-$ or EP-653392-$ or DE-10025198-$).did.	US-PGPUB; USPAT; USOCR; DERWENT	ADJ	ON	2008/05/30 12:39
S41	261	(silicon nitride) AND crucible AND "117".clas.	US-PGPUB; USPAT; USOCR	ADJ	ON	2008/05/30 13:55
S42	59	S41 and (pore OR porous OR porosity)	US-PGPUB; USPAT; USOCR	ADJ	ON	2008/05/30 13:55
S43	163	(silicon nitride) AND "117".clas. and (pore OR porous OR porosity)	US-PGPUB; USPAT; USOCR	ADJ	ON	2008/05/30 14:34
S44	104	S43 NOT S42	US-PGPUB; USPAT; USOCR	ADJ	ON	2008/05/30 14:34
S45	2800	silicon nitride and hot (press OR pressing)	US-PGPUB; USPAT	ADJ	ON	2008/05/30 14:44
S46	1978	S45 and (coating OR coat OR film)	US-PGPUB; USPAT	ADJ	ON	2008/05/30 14:44
S47	20	S46 and (silicon crystal)	US-PGPUB; USPAT	ADJ	ON	2008/05/30 14:44
S48	251	S41 and crystal	US-PGPUB; USPAT; USOCR	ADJ	ON	2008/05/30 14:45
S49	197	S48 NOT (S42 OR S44)	US-PGPUB; USPAT; USOCR	ADJ	ON	2008/05/30 14:46

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